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| Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i> | Docket Number 325772020700 | Application Number to be assigned 09/735,608 |
| | Applicant Hiroshi HATANO | |
| | Filing Date December 14, 2000 | Group Art Unit to be assigned 2653 |
| | | |

U.S. PATENT DOCUMENTS

| Examiner Initials | Ref. No. | Date | Document No. | Name | Class | Subclass | Filing Date If Appropriate |
|-------------------|----------|------------|--------------|-----------------|------------|---------------|----------------------------|
| KL | 1. | 07-28-1998 | 5,786,947 | MAEDA et al. | 359 | A22 | / |
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| KL | 6. | 07-28-1995 | 7-192280 | Japan | / | / | abstract |

OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

| Examiner Initials | Ref. No. | Title |
|-------------------|----------|-------|
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EXAMINER: (examiner)

Kim Chun

DATE CONSIDERED:

7/2/04

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

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 09/735608
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